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#5/GLE
6/25/2
Supter

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER 2809

RECEIVED
JUN 21 2002

In re application of

Docket No: Q63516

Eun-kyung LEE, et al.

Appln. No.: 09/835,319

Group Art Unit: 2881

Confirmation No.: 5337

Examiner: Armando RODRIGUEZ

Filed: April 17, 2001

For: MULTI-WAVELENGTH SURFACE EMITTING LASER AND METHOD FOR
MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

This paper is responsive to the Office Action mailed on May 22, 2002, for the above-identified application.

Applicants elect, Group I, claims 1, 2, 6-10 & 16-18 with out traverse.

Applicants reserve the right to file Divisional Applications directed to the non-elected Group II.

Respectfully submitted,

Darryl Mexic
Registration No. 23,063

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